15977-29

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
SUNGHO JIN	:	Examiner: NYA
National Phase Application under 35 U.S.C. 371 of International Application No.: PCT/US2004/010489	) : ) :	TC/Art Unit: NYA
International Filing Date: April 6, 2004	)	
For: HIGH RESOLUTION ELECTROLYTIC LITHOGRAPHY, APPARATUS THEREFOR AND RESULTING PRODUCTS	) : )	October 6, 2005
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		• .
PRELIMINARY AME	END	<u>MENT</u>

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Prior to examination on the merits, please amend the above-identified

application as follows: